

ABSTRACT

A subject of the invention is to reduce the temperature dependence of an etalon as a wavelength locker for a semiconductor laser device and so forth. Concretely, it is to restrict the lowering of the wavelength locking performance of the etalon dependent on the temperature variation. A means to solve the subject is the use of an air gap etalon. Concretely, the means is provided with a media plate and parallel plane plates on both sides of the media plate. The two parallel plane plates and the space between them constitute the air gap etalon.

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